



First Named

Inventor : Huaqing Yin, et al.

Appln. No. : 10/607,779

Filed : June 27, 2003

Title : HARD MASK METHOD OF FORMING A READER  
OF A MAGNETIC HEAD

Docket No. : I69.12-0590

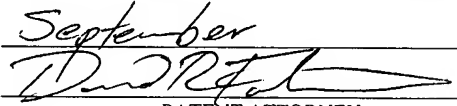
Group Art Unit:

Examiner:

### INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I CERTIFY THAT THIS PAPER IS BEING SENT BY U.S. MAIL,  
FIRST CLASS, TO THE ASSISTANT COMMISSIONER FOR  
PATENTS, WASHINGTON, D.C. 20231, THIS 15 DAY OF

September, 2003.  
  
PATENT ATTORNEY

Sir:

The enclosed PTO Form-1449 lists patents and publications submitted pursuant to 37 C.F.R. 1.97.

Copies of the patents or publications are enclosed as necessary.

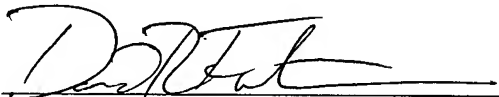
#### TIME OF FILING

The Information Disclosure Statement is being filed:

1. X with the application or within three months of the filing date of a national application (other than a continued prosecution application under 37 C.F.R. 1.53(d)) or date of entry into the national stage of an international application or, to the best of the undersigned's knowledge, before the mailing date of a first Office action on the merits or a first office action after the filing of a request for continued examination under 37 C.F.R. 1.114, whichever event occurs last. In accordance with 37 C.F.R. 1.97(b), no certification or fee is required.

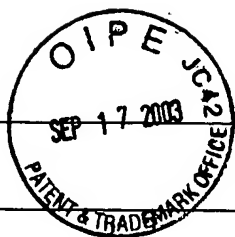
Respectfully submitted,

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FORM PTO-1449	Atty. Docket No.: I69.12-0590	Application No.: 10/607,779
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	First Named Inventor: Huaqing Yin, et al.	
	Filing Date: June 27, 2003	Group Art:

## U.S. PATENT DOCUMENTS

Examiner Initials	Document No.	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents
AA	4,949,039	08-14-1990	Grünberg
AB	5,772,493	06-30-1998	Rottmayer et al.
AC	5,777,542	07-07-1998	Ohsawa et al.
AD	5,793,279	08-11-1998	Nepela
AE	5,861,328	01-19-1999	Tehrani et al.
AF	6,183,890	02-06-2001	Fujita
AG	6,411,478	06-25-2002	Mao et al.
AH	6,469,876	10-22-2002	Sasaki et al.
AI	6,475,922	11-05-2002	Zheng
AJ			
AK			

## FOREIGN PATENT DOCUMENTS

	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Documents	Translation Yes No
AL				
AM				
AN				

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AO	"Advances in Dry Etching of GMR Materials", James M. Klemm and Edward W. Ostan., <a href="http://semiconductors.unaxis.com/en/chiponline_72dpi/issue4/c4p28_72.pdf">http://semiconductors.unaxis.com/en/chiponline_72dpi/issue4/c4p28_72.pdf</a> .
AP	
AQ	

EXAMINER:	DATE CONSIDERED:
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	